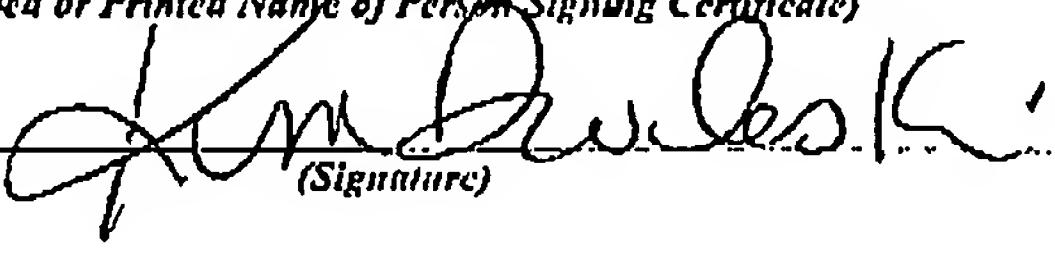


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)				Docket No. BUR920040122US1
Applicant(s): Cline et al.	Application No. 10/711,953	Filing Date 10/15/2004	Examiner Chen, Eric Brice	Group Art Unit 1765
Invention: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION				
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<p>I hereby certify that this <u>Request for Reconsideration (14 pages)</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>)</p> <p>on <u>12/5/2005</u> (Date)</p>				
<p>Kim Dwilecki (Typed or Printed Name of Person Signing Certificate)</p> <p> (Signature)</p>				
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cline *et al.*

Examiner: Chen, Eric Bricc

Serial No.: 10/711,953

Art Unit: 1765

Filed: 10/15/2004

Docket No.: BUR920040122US1

Title: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Request for Reconsideration

Sir:

This Request for Reconsideration is in response to the Office Action mailed September 7, 2005.

10/711,953

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